

BULK MODULUS OF II-VI AND III-V SEMICONDUCTORS

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Abstract: A semi-empirical formula has been proposed in this paper to calculate bulk modulus of Zinc blende structured III -V and II-VI semiconductors in terms of bond hardness. Bond hardness is calculated using valence electron number, covalent / ionic radius and co-ordination number of bonded atoms of the tetrahedral semiconductors. To calculate the resultant bond hardness covalent and ionic contributions to bond hardness are separately calculated. Results obtained using the proposed relation agrees well with the experimental and theoretical values of other researchers.

Keywords: bond hardness, atomic stiffness, bulk modulus, ionicity.

1. INTRODUCTION

The bulk modulus of binary semiconductors and their alloys has been extensively investigated. It has been one of the important parameters for studying physical and mechanical properties [1-6] of materials systems. Since it is related to deformation against external force of materials its measurement is useful for microhardness and mechanical test of materials. The study of bulk modulus of anisotropic materials is essential for coating materials in photovoltaic application, fiber reinforced composites, polycrystalline textured materials, biological tissues etc [7]. As the bulk modulus involves change in volume and stress (pressure) developed and is sensitive to variation in the equation of state, it has provided basis for study of earth deep interior [8]. Various researchers have proposed empirical relations for calculating bulk modulus of binary semiconductors [9-11]. But the calculated and reported results are not in good agreement with available experimental values. The reported values also differ widely among themselves in some cases. This gives scope for further investigation on calculation of bulk modulus of binary semiconductors. This paper is an attempt in this direction in which a new relation has been proposed for calculating bulk modulus of elemental and binary semi-conductors. we have made an attempt to propose a correlation between bulk modulus and bond hardness of II-VI and III-V binary semiconductors.

2. THEORETICAL APPROACH

The tetrahedral semiconductors (II-VI and III-V) are partially ionic. It is evident from the recent studies [12-15] on bulk modulus and hardness of covalent and ionic crystals that the ionic materials always possess relatively lower hardness [16] and superhard materials have strong covalent bonds; high valence electron density, large modulus and large strength [17]. But the earlier model of ionicity [18] exhibit the trend opposite to above mentioned fact. Recently, we have proposed a new model of ionicity [19] the results of which are in conformity with the trend of variation of hardness/bulk modulus with ionicity. So we have utilised the ionicity/ covalency, wherever required from our model.

It is argued that bond hardness must reflect its signature in microhardness. In other words microhardness should increase (decrease) with increase (decrease) of bond hardness. But the bond between atoms of a tetrahedral semiconductor being partially ionic and partially covalent, we intend to compute the bond hardness considering the covalent and the ionic contributions separately and then obtaining the resultant of them. In this attempt, we using Li and Xue [28] define the electron holding energy of atoms with a covalent bond as

$$E_c = Z / R^c \quad (1)$$

and the electron holding energy of an atom with an ionic bond as

$$E_i = Z / R^i \quad (2)$$

where Z is the number of valence electrons and $R^{c(i)}$ is the covalent (ionic) radius of the i^{th} atom. Accordingly, the atomic stiffness is expressed as

$$S^{c(i)} = E_{c(i)} / (R^{c(i)})^3 \quad (3)$$

The hardness of the covalent(ionic) bond a-b of a compound 'ab' defined as the electron- holding energy of the bond per unit volume, is given by the geometric mean of atomic stiffness per bond of atoms, i.e

$$H_{ab}^{c(i)} = (S_a^{c(i)} S_b^{c(i)} / C_{Na} C_{Nb})^{0.5} = (Z_a Z_b / C_{Na} C_{Nb})^{0.5} / (R_a^{c(i)})^2 (R_b^{c(i)})^2 \quad (4)$$

where C_{Ni} ($i = a, b$) is the co-ordination number of the i^{th} atom. Covalent and ionic contribution to bond hardness of II-VI and III-V semiconductors was calculated using Eq. (4). The resultant bond hardness is given by

$$H_{ab} = H_{ab}^c f_c + H_{ab}^i f_i \quad (5)$$

where H_{ab}^c is the covalent contribution to the bond hardness, H_{ab}^i is the ionic contribution to the bond hardness, f_c is the covalency and f_i is the ionicity of the bond a-b.. The value of ionicity (f_i) and covalency (f_c) have been obtained from our newly proposed model [26], and accordingly the resultant bond hardness has been

calculated. The available experimental values of bulk modulus (B in GPa) of III-V and II-VI semiconductors were then plotted against the computed bond hardness, H_{ab} (in GPa) (Eq. 5). Plots are linear (Fig. 1 and 2) with correlations of 0.9915 and 0.9923 respectively for III-V and II-VI semiconductors indicating strong linear dependence of bulk modulus on bond hardness.

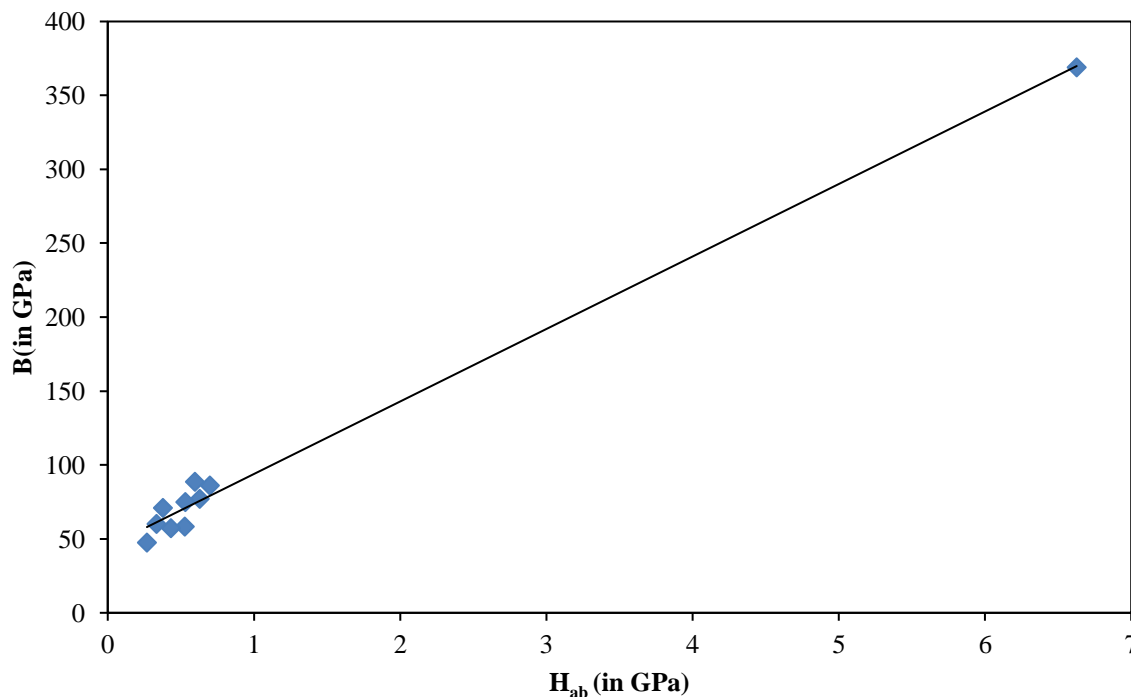


Fig. 2.1 Plot of bulk modulus, B versus bond hardness, H_{ab} for III-V semiconductors

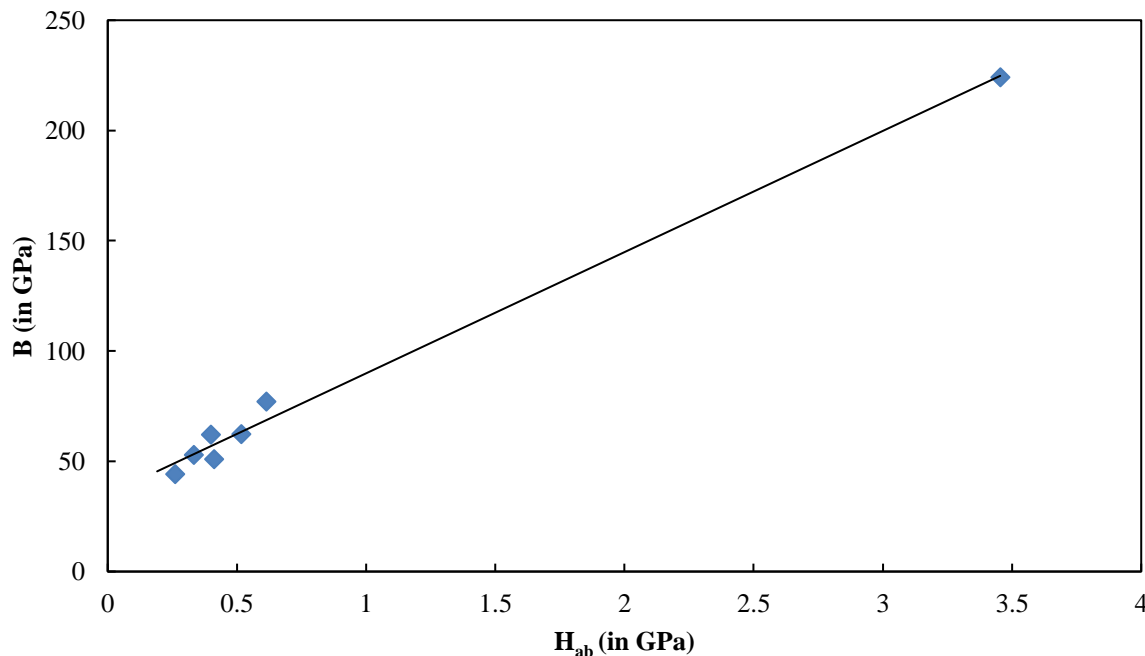


Fig. 2.2 Plot of bulk modulus, B versus bond hardness, H_{ab} for II-VI semiconductors

Accordingly, the following relation is proposed for bulk modulus in terms of bond hardness

$$B = a H_{ab} + b \tag{6}$$

Where a and b are the fitting parameters. The values of ‘a’ and ‘b’ are proposed as 48.71, 45.03 and 55.09, 34.557 for group III-V and II-VI semiconductors respectively. This relation has been utilised in the prediction of bulk modulus of other III-V and II-VI semiconductors for which the experimental values to the best of our knowledge is not available.

3. RESULTS AND DISCUSSION

Calculated values bond hardness, H_{ab} along with f_i and f_c of the systems are presented in Table I. Bulk modulus of semiconductors belonging to III-V and II-VI are given in Table II. For comparison experimental and the reported values are also given. Values of bulk modulus obtained using proposed Eq.(6) are in reasonable agreement with the experimental values.

Table-3.1 Calculated Bond Strength (H_{ab} in GPa) using Eq. (5), bond ionicity(f_i) and bond covalency (f_v) for Gr. III-V and II-VI semiconductors

Systems		f_i Ref. [21]	f_c Ref. [22]	H_{ab} (in GPa) (Eq.5)
III-V	BN	0.158	0.842	6.627
	BP	0.227	0.773	4.898
	BAS	0.243	0.757	4.650
	BSb	0.276	0.724	4.175
	AlN	0.216	0.784	1.228
	AlP	0.298	0.702	0.697
	AlAs	0.312	0.688	0.628
	AlSb	0.348	0.652	0.527
	GaN	0.224	0.776	1.177
	GaP	0.297	0.703	0.598
	GaAs	0.314	0.686	0.532
	GaSb	0.348	0.652	0.431
	InN	0.262	0.738	0.749
	InP	0.329	0.671	0.377
	InAs	0.343	0.657	0.334
	InSb	0.375	0.625	0.268
II-VI	BeO	0.453	0.547	3.454
	BeS	0.573	0.427	2.288
	BeSe	0.596	0.404	2.003
	BeTe	0.637	0.363	1.674
	ZnO	0.547	0.453	1.081
	ZnS	0.626	0.374	0.615
	ZnSe	0.647	0.353	0.517
	ZnTe	0.679	0.321	0.411
	CdO	0.602	0.398	0.721
	CdS	0.660	0.340	0.399
	CdSe	0.676	0.324	0.332
	CdTe	0.705	0.295	0.261
	HgS	0.661	0.339	0.305
	HgSe	0.678	0.322	0.249
	HgTe	0.705	0.295	0.191

Table-3.2 Bulk Modulus, B (in GPa) of Gr. III-V and II-VI semiconductors obtained from bond hardness [Eq. (6)] along with experimental and reported values

System		Bulk modulus, B (in GPa)					
		This study	Exp.			Reported values	
			Ref.8	Ref9	Ref. 10	Ref. 1	Ref. 27
III-V	BN	367.838	367	346	367	351.2	152.06
	BP	283.616	165	165	166	154.1	131.49
	BAS	271.536		138	138		118.7
	BSb	248.398					
	AlN	104.847					
	AIP	78.982	86	80.5	86.7	86.3	87.77
	AlAs	75.669	77	74	78.3	78.3	79.08
	AlSb	70.701	58.2	54.1	57	59	58.45
	GaN	102.363					133.58
	GaP	74.159	88.7	81.5	86.7	86.3	86.34
	GaAs	70.944	74.8	72.4	76.1	76.1	75.12
	GaSb	66.024	57	55.4	57.8	59.6	54.86
	InN	81.515					107.59
	InP	63.394	71	60.8	67	68.7	69.19
	InAs	61.299	60	56.3	61	62.8	62.11
InSb	58.085	47.4	44	47.1	49.4	47.88	
II-VI	BeO	224.855					303.17
	BeS	160.628		120			113.11
	BeSe	144.900		105			96.55
	BeTe	126.759		78			68.81
	ZnO	94.129					146.19
	ZnS	68.428	77.1	73.3	78.1	72	75.31
	ZnSe	63.052	62.4	65.1	66.5	63.9	65.3
	ZnTe	57.211	51	51.9	51.2	52.2	55.74
	CdO	74.270					
	CdS	56.550	62	53.2	60.3	59.5	56.79
	CdSe	52.866	53		52.6	53.9	49.67
	CdTe	48.938	42.4	40.2	41.2	44	43.32
	HgS	51.350					56.52
	HgSe	48.268	50		51.9	53	49.52
	HgTe	45.091	42.3			45.7	41.87

Group properties are clearly reflected in the results. The magnitude of bulk moduli follows the order BeO > BeS > BeSe > BeTe ; ZnO > ZnS > ZnSe > ZnTe; CdO > CdS > CdSe > CdTe and HgS > HgSe > HgTe in II-VI semiconductors; and BN > BP > BAs > BSb ; AlN > AlP > AlAs > AlSb ; GaN > GaP > GaAs > GaSb and InN > InP > InAs > InSb in III-V semiconductors. For any system containing element(s) going down a group, the bulk modulus decreases. This is due to increase in size of the atom and also due to increase in ionicity caused by increasing bond length.

It is also interesting to note that compounds involving the elements from the carbon row exhibit high bulk moduli. For example BN (367.83 GPa), AlN (104.87 GPa), GaN(102.36 GPa), InN(81.51 GPa), BeO (224.85 GPa), ZnO (94.12 GPa), CdO (74.27 GPa) etc. have higher values of bulk modulus. In case of BeO, BeS, ZnO, and CdO the experimental values, to the best of our knowledge, are not available, so we have quoted the calculated values, which appear to be reasonable as they agree well with other reported values. For CdO, BSb too, reported values are not available.

The high values of bulk modulus of compounds made up of C-row element(s) might be due to non-availability of p-sub shells in the core of atoms of such elements which allows valence electron orbitals to penetrate deeper while forming bonds with atoms of other elements leading to formation of strong bonds, and hence higher bulk

moduli. With the increase in number of p- sub shells, the bond between atoms of the systems weakens and the bulk modulus decreases.

The ionicity and metallicity too appear to affect bulk modulus. Its magnitude decreases with the ionicity, the order, in general, as we move from group III –V to II-VI semiconductors. However, for a given cation the ionicity decreases as the anion goes down the group. The bulk modulus follows the same trend indicating that some other factors must play the role to balance the effect of ionicity. Metallization energy decreases [28] as one goes down a group and it causes decrease in bulk modulus.

CONCLUSION

Bond hardness of binary semiconductors been calculated. The idea inclusion of covalent and ionic contributions to the bulk modulus through bond hardness has been utilised which appear logical. Linear correlation between bulk modulus and bond hardness, proposed for III-V and II-VI semiconductors. Bulk modulus of CdO and BSb has been predicated for the first time. The proposed relation has also been utilised to predict the bulk modulus of III-V and II-VI semiconductors' which is in reasonable agreement with the reported value, and its applicability can also be extended to other ternary and quaternary alloys.

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